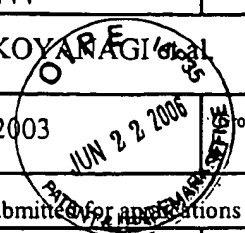


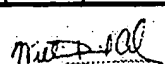
<b>APPLICANT'S ART CITATION</b> (Use several sheets if necessary)		Application 10/630,444		OFGS File No. P/3236-39	
		Applicant Kenichi KOYAGI			
		Filing Date July 29, 2003		Group Art Unit 2812	



U.S. PATENT DOCUMENTS (not submitted for applications filed after 6/30/03)						
Examiner Initial	Document Number	Date MM-YYYY	Name	Class	Sub-class	Filing Date If Appropriate
WC	US-2002/0086476	07-2002	Kim, et. al.			
	US-					
	US-					
	US-					
	US-					
	US-					
	US-					
	US-					
	US-					
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FOREIGN PATENT DOCUMENTS							
	Document Number	Date MM-YYYY	Country	Class	Sub-class	Translation	
						Yes	No
WC	9-77593	03-1997	Japan				X
WC	2001-220676	08-2001	Japan				X
WC	2001-160616	06-2001	Japan				X
WC	2001-127258A	05-2001	Japan				X
WC	9-121035	05-1997	Japan				X

OTHER DOCUMENTS (Including Author, Title, Date, Pertinent Pages, Etc.)		
WC		Untranslated Office Action issued by Japanese Patent Office on March 22, 2006 in
WC		connection with corresponding application no. 2002-220468
WC		English translation of relevant portions of Examiner's comments in Japanese Office Action
WC		issued 03/22/06 submitted in lieu of statement of relevancy of prior art to present invention

Examiner 	Date Considered 07/27/2006
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